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Dated: 3/29/2006 Signature: Jo-Ann Bergantino
(Jo-Ann Bergantino)

Docket No. 007734 FPS/MMCS/APC
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Young J. PAIK

Application No.: 10/665165

Confirmation No.: 6290

Filed: September 18, 2003

Art Unit: 1763

For: FEEDBACK CONTROL OF A CHEMICAL
MECHANICAL POLISHING PROCESS FOR
MULTI-LAYERED FILMS

Examiner: S. MacArthur

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated October 3, 2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.